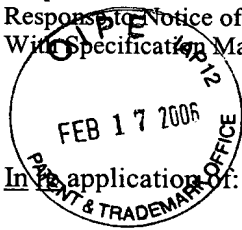


Application No: 10/722,729  
Response dated 2/15/06  
Response to Notice of Drawing Inconsistency  
With Specification Mailed 1/24/06



*IFW*  
**PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Bright et al.

Application No: 10/722,729

Filed: November 25, 2003

For: APPARATUS FOR CONTROLLING WAFER  
TEMPERATURE IN CHEMICAL MECHANICAL  
POLISHING

) Attorney Docket No: LAM2P318C

) Examiner: G.B.M. Nguyen

) Group Art Unit: 3723

) Date: February 15, 2006

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on February 15, 2006.  
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*Kay Harlow*  
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Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Letter to Office of Patent Publication/Publishing Division  
Response to Notice of Drawing Inconsistency With Specification

In response to the Notice of Drawing Inconsistency With Specification mailed 1/24/06, which set a 30 day period for response, please amend the specification of the captioned application as set forth on page 2 of this paper and consider the Remarks on page 3 of this paper.